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PATENT

Docket No. JCL A7567Date 10-30-2001

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ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231
ATTENTION: APPLICATION BRANCH

Sir:

Transmitted herewith for filing is the patent application of

Inventors: Ming-Yu Lin; Wei Ming Chen; Yen-Chih Huang; Shih-Feng Lin
For: METHOD FOR MONITORING DYNAMIC PARTICLE POLLUTION IN AN
ETCHING CHAMBER

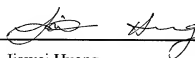
Enclosed are:

- ☒ Specification 12 pages.
☒ 2 Sheets of drawings
☒ Recordation Form Cover sheet with 2 pages assignment.
☐ A certified copy of Taiwan Patent Application No. dated .
☒ **SIGNED** declaration and power of attorney.
☒ Return Prepaid postcard.

CLAIMS AS FILED

FOR	NUMBER FILED			NUMBER EXTRA	RATE	FEE
Basic Fee					\$740.00	\$740.00
Total Claims	9	—	20 =	0 ×	\$18.00	\$0.00
Independent Claims	1	—	3 =	0 ×	\$84.00	\$0.00
If application contains any multiple dependent claim (s), then add					\$280.00	\$0.00
TOTAL FILING FEE						\$740.00

- ☒ A check in the amount of \$740.00 cover the filing fee is enclosed.
☒ A check in the amount of \$40.00 to cover the assignment recording fee.
☒ A duplicate copy of this sheet is enclosed.



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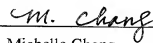
CERTIFICATE OF MAILING BY "EXPRESS MAIL"

Docket No. : JCLA7567
Applicant(s) : Ming-Yu Lin; Wei Ming Chen; Yen-Chih Huang;
Shih-Feng Lin
For : METHOD FOR MONITORING DYNAMIC
PARTICLE POLLUTION IN AN ETCHING
CHAMBER
"Express Mail" : EL 857833140 US
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Date of Deposit : October 30, 2001

I hereby certify that the accompanying

Transmittal in Duplicate; Specification 12 pages, 2 sheets of drawings; **SIGNED**
Declaration and Power of Attorney 2 pages; Recordation Form Cover Sheet and
Assignment 3 pages; Checks for Filing Fee(s); Return Prepaid Postcard

are being deposited with the United States Postal Service "Express Mail Post Office to
Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the
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Michelle Chang